

0163-0707-2X



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF : *TM KB*

Kenji MIWA et al : GROUP: 1722

SERIAL NO: 09/158,099 : *11/21/00*

FILED: September 22, 1998 : EXAMINER: PACHECO , L.

FOR: METHOD OF REFINEMENT OF :
MICROSTRUCTURE OF...

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Responsive to the Official Action mailed May 15, 2000, please amend the above-identified patent application, as follows:

IN THE SPECIFICATION

Please amend the specification as follows:

Page 1, lines 1-4, delete in their entirety and substitute therefor:

-TITLE OF THE INVENTION

METHOD OF REFINEMENT OF MICROSTRUCTURE OF METALLIC MATERIALS

BACKGROUND OF THE INVENTION

Field of the Invention:-;

line 18, delete in its entirety and substitute therefor:

Detailed description of the Prior Art

RC 1700 MA
NOV 16 2000
RECEIVED